



Docket No.: 740819-430

#9/Prior art
11/5/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Shinji NAKAMURA et al.)
Serial No. 09/680,054)
Filed: October 5, 2000)
For: SEMICONDUCTOR DEVICE, SEMICONDUCTOR)
SUBSTRATE, AND MANUFACTURE METHOD)

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REQUEST FOR ACKNOWLEDGMENT FOR
CONSIDERATION OF DISCLOSED INFORMATION

Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

An Information Disclosure Statement with Form PTO-1449 was filed in the above-captioned patent application on March 26, 2001. Applicants have not yet received back from the Examiner a copy of the Form PTO-1449 initialized to acknowledge the fact that the Examiner has considered the cited disclosed information.

The Examiner is requested to initial and return to the undersigned a copy of the subject Form PTO-1449.

Should there be any questions concerning this communication, please telephone the undersigned at the number set forth below.

Respectfully submitted,

Donald R. Studebaker
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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on 10-11-02